

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/678,994	SHIMADA, HIROYUKI		
Examiner	Art Unit		
Kin-Chan Chen	1765		

SEARCHED								
CI	ass	Subclass	Date		Examiner			
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INTERFERENCE SEARCHED							
Class	Subclass	Date	Examiner				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)						
	DATE	EXMR				
East Keyworksearch US pst, US psq-pul. Epo, Jpo, Denvent JBM-TOB.						
inventor rearch	5-14-05	K-cc				
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